



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/530341 Confirmation No. N/A
 Applicant : Yoshiyuki Nakamizo et al.
 Filed : April 1, 2005
 TC/A.U. : N/A
 Examiner : N/A

 Title : SEMICONDUCTOR ACCELERATION SENSOR AND
 PROCESS FOR MANUFACTURING THE SAME
 Docket No. : NIS-16035
 Customer No. : 040854

INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Sir/Madam:

In accordance with Rule 56, applicant is aware of the publications listed in the International Search Report (Copy enclosed) and in the enclosed copy of Patent Office Form PTO/SB/08A. A copy of each of the publications is enclosed herewith.

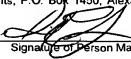
Respectfully submitted,

RANKIN, HILL, PORTER & CLARK LLP

By 
 David E. Spaw, Reg. No. 34732

4080 Erie Street
 Willoughby, Ohio 44094
 (216) 566-9700

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date indicated below.


 Signature of Person Mailing Paper

6/9/05 David E. Spaw
 Date Printed Name of Person Mailing Paper

